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Our Case No. 9281-4017

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

Hitoshi Seki et al.

Serial No. 09/595,415

Filing Date: June 16, 2000

For: ETCHING REAGENT, AND METHOD  
FOR MANUFACTURING ELECTRONIC  
DEVICE SUBSTRATE AND  
ELECTRONIC DEVICE

)  
)  
) Examiner:  
) Shamim Ahmed  
)  
)  
) Group Art Unit:  
) 1765  
)

**AMENDMENT AND RESPONSE UNDER 37 C.F.R. § 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action dated December 9, 2004, in the above-referenced application, please reconsider the rejection in view of the amendment and remarks presented herein.

The Applicants believe entry of the accompanying amendment will place their application in condition for allowance. Accordingly, please amend the application as follows.

Applicants' amendments to the claims begin at page 2 of this paper.

The Applicants' remarks begin at page 5 of this paper.